

Optimum Electron Distribution for Space Charge Dominated Beams

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- Minimum emittance
- 3D-Ellipsoidal electron bunch
 - Emittance performances compared to “Beer Can”
 - Linear Longitudinal Phase Space
 - Optimization for S-Band and L-Band guns
 - Sensitivity
- Generation of 3D-ellipsoidal laser pulse
 - “First thoughts”
- Conclusions

Intrinsic Limits of Minimum emittance

$$\mathcal{E}_{tot} = \sqrt{\mathcal{E}_{cathode}^2 + \mathcal{E}_{RF}^2 + \mathcal{E}_{space\ charge}^2}$$

■ Cathode “Intrinsic” emittance

- for copper measured 0.6 mm.mrad per mm of r_{laser} [1,2,3]
theoretical is 0.3 mm.mrad per mm of r_{laser}

$$\mathcal{E}_{cathode} = \sqrt{\mathcal{E}_{thermal}^2 + \mathcal{E}_{roughness}^2 + ??}$$

$$\mathcal{E}_{cathode} \propto r_{laser\ spot}$$

- Minimum r_{laser} set by “Space Charge Limit”

Minimum r_{laser} or electrons cannot leave cathode (for metal cathodes)

- $R_{min.} = 0.82$ mm at 54 MV/m for a 1nC
- $R_{min.} = 1.34$ mm at 20 MV/m for a 1nC

$$E = \frac{\sigma}{\epsilon_o} = \frac{Q}{\pi r^2 \epsilon_o} < E_{peak} \sin \phi$$

■ RF emittance

- small ϵ_{RF} ($10^\circ, r = 1.2$ mm, $Q = 1$ nC) < 0.15 mm.mrad for S-Band gun

■ Space Charge

- Emittance compensation to correct for linear space charge effects;
- Non-linear components of SC forces can not be compensated for with linear optics elements

Uniform charge density inside 3D-Ellipsoid volume = Ideal Emitted pulse

- Charge density remains uniform over volume as the space charge force is linear
- Perfect emittance compensation is achieved with linear optics elements
- $\Rightarrow \epsilon_{space\ charge} = 0$

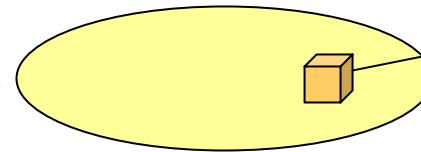
$$\mathcal{E}_{tot} \sim \mathcal{E}_{cathode}$$

Ellipsoidal Emission pulse

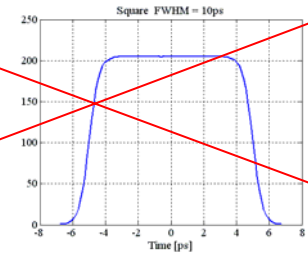
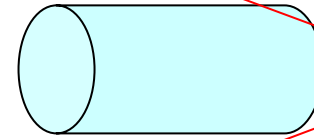
- “Beer Can” shape is NOT the optimum shape
- Ideal Emitted pulse = Ellipsoid

Electrons are uniformly distributed inside a 3D ellipsoid volume

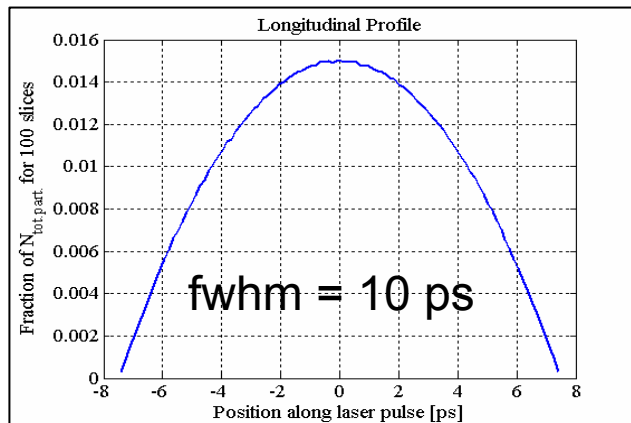
$$\frac{x^2}{a^2} + \frac{y^2}{b^2} + \frac{z^2}{c^2} = A^2$$



$$\frac{N}{dx dy dz} = \text{const.}$$

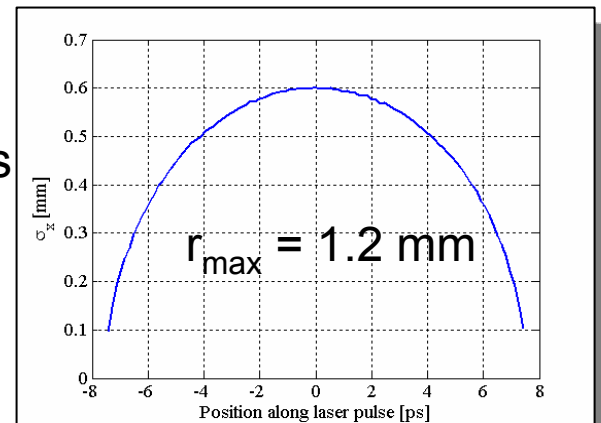


Line
Density

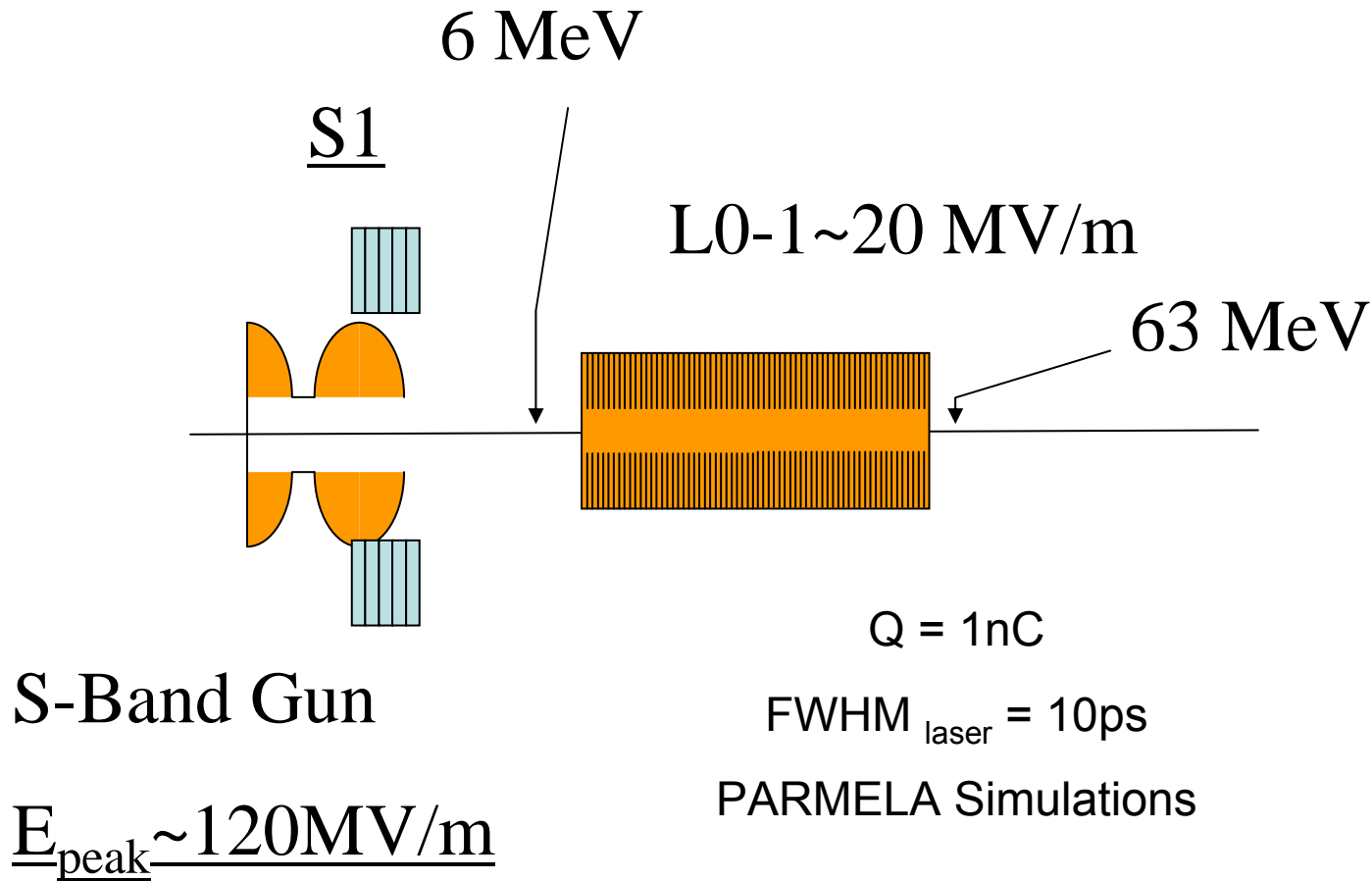


Pulse length

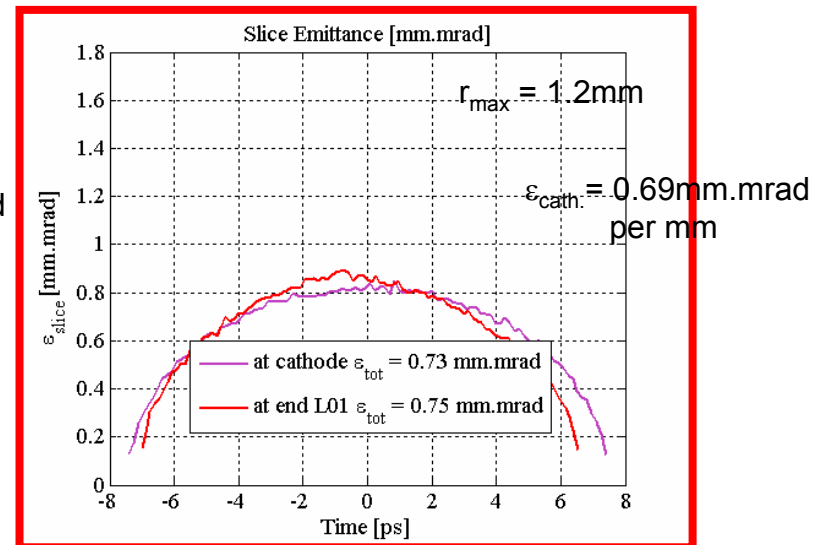
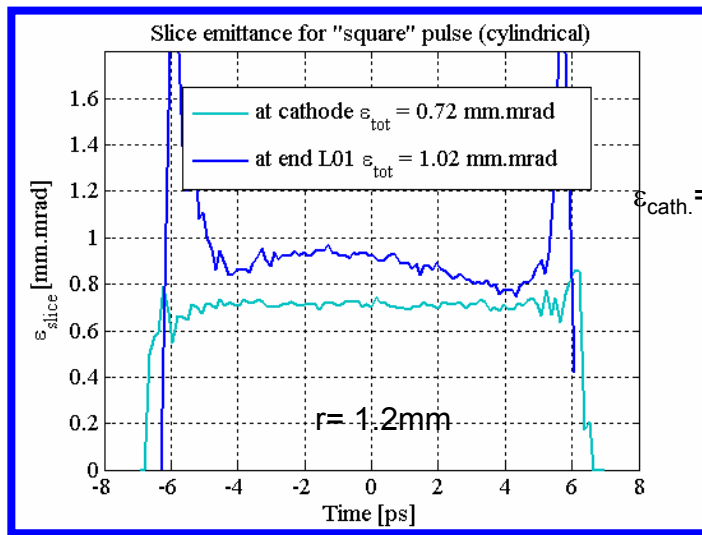
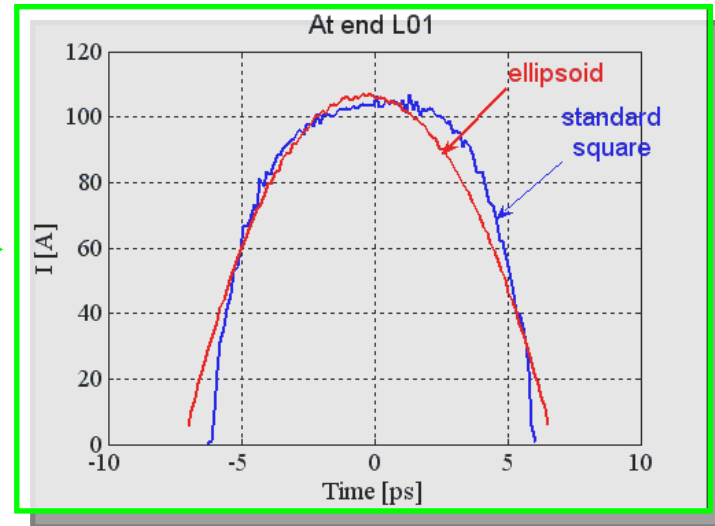
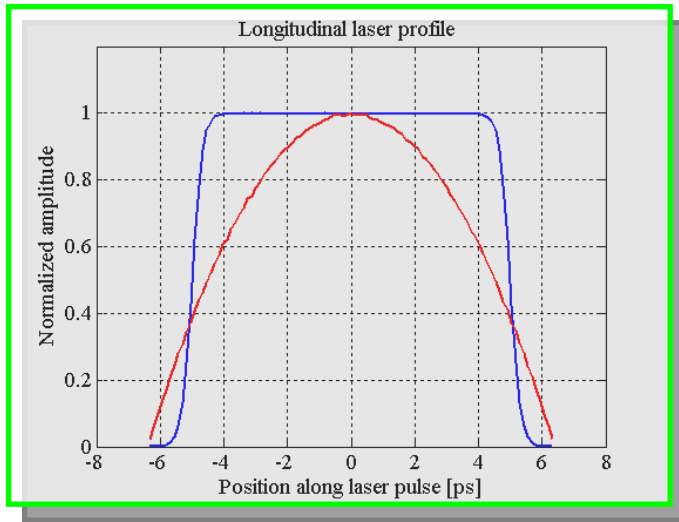
Radius



Pulse length

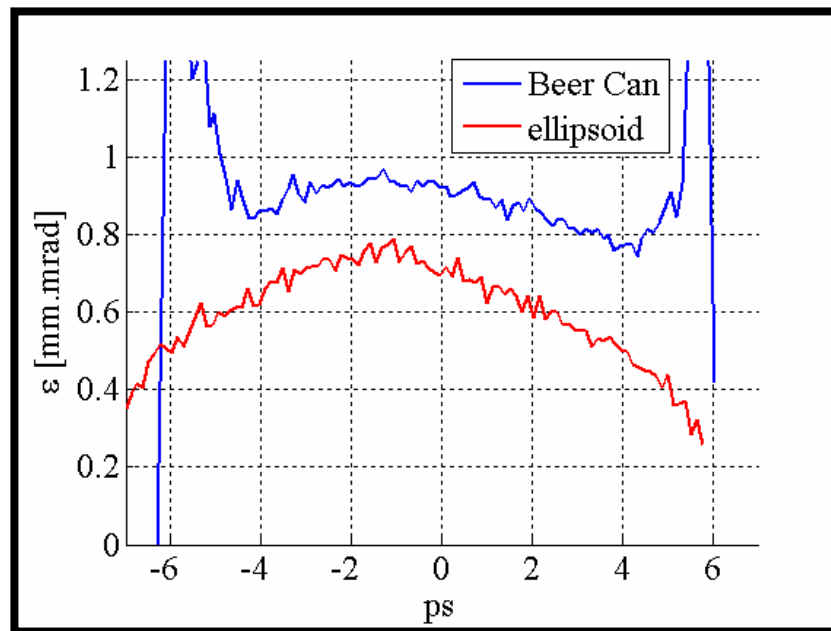


Comparison between "beer can" & "3D ellipsoid"



Comparison between “beer can” & “3D ellipsoid”

3D ellipsoid is even better optimized with $r_{\max} = 1\text{mm}$

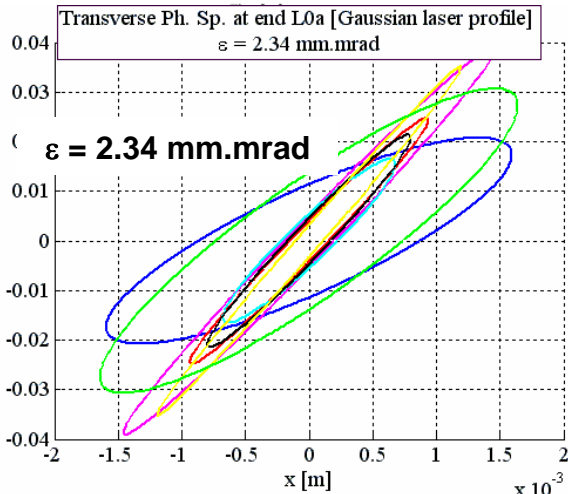
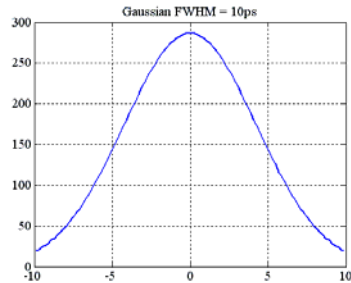


$\varepsilon = 1.02 \text{ mm.mrad}$; $\varepsilon_{80\%} = 0.95 \text{ mm.mrad}$ (with standard $\varepsilon_{\text{cathode}} = 0.6$)

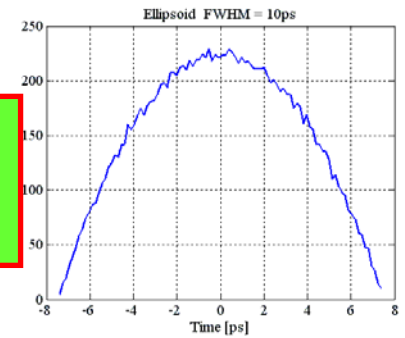
$\varepsilon = 0.71 \text{ mm.mrad}$; $\varepsilon_{80\%} = 0.71 \text{ mm.mrad}$ (with overestimated $\varepsilon_{\text{cathode}} = 0.7$)

Transverse Ph.Space

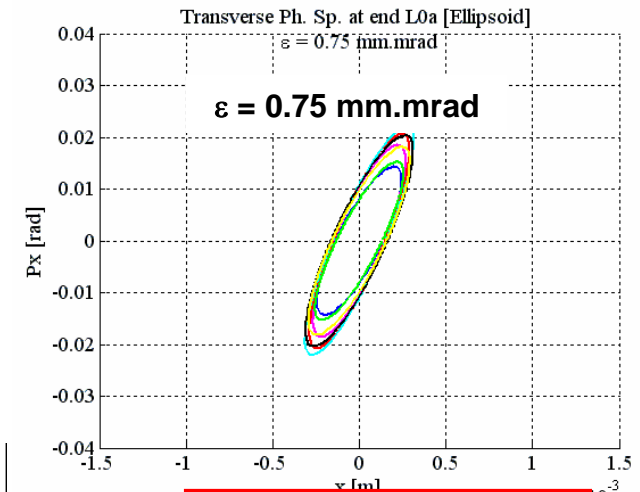
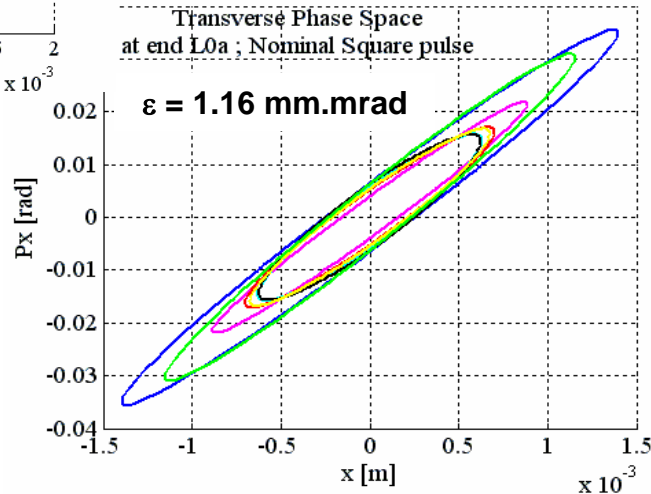
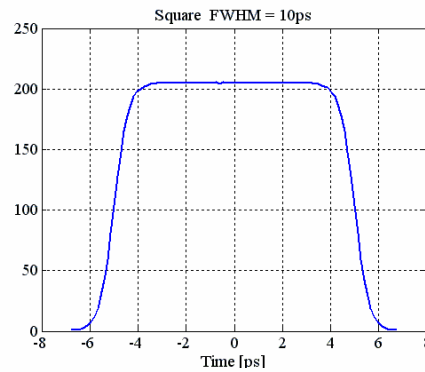
Gaussian



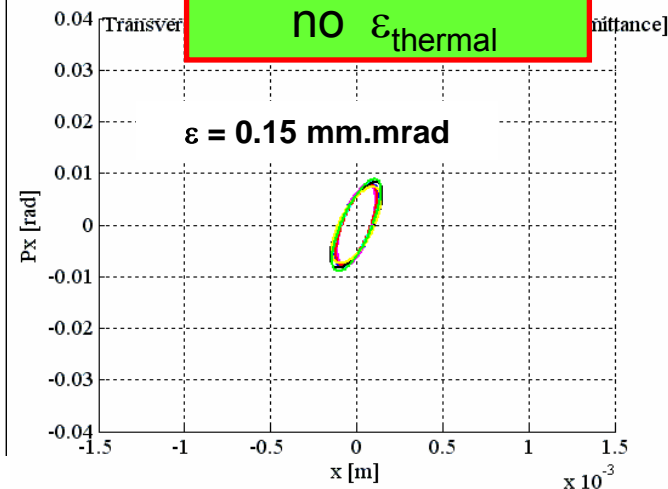
Ellipsoid
with $\epsilon_{\text{thermal}}$



Square pulse



NO $\epsilon_{\text{thermal}}$

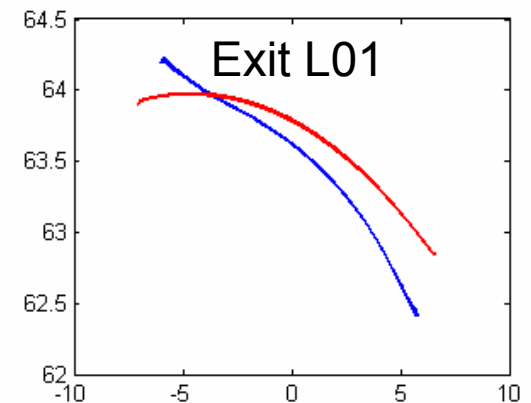
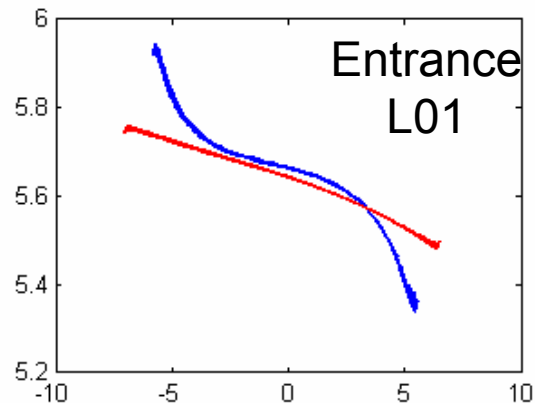
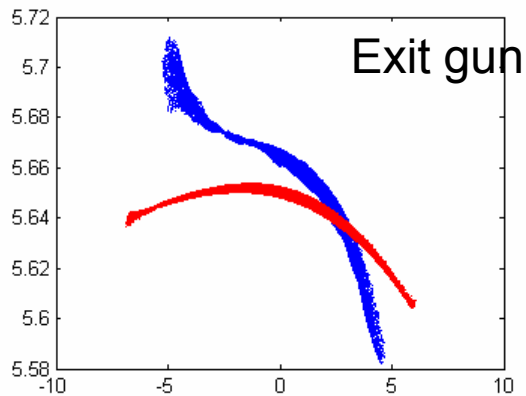


Linear Longitudinal Phase Space

— Beer can
— 3D-ellipsoid

Longitudinal Phase Space

E_k [MeV] vs T [ps]

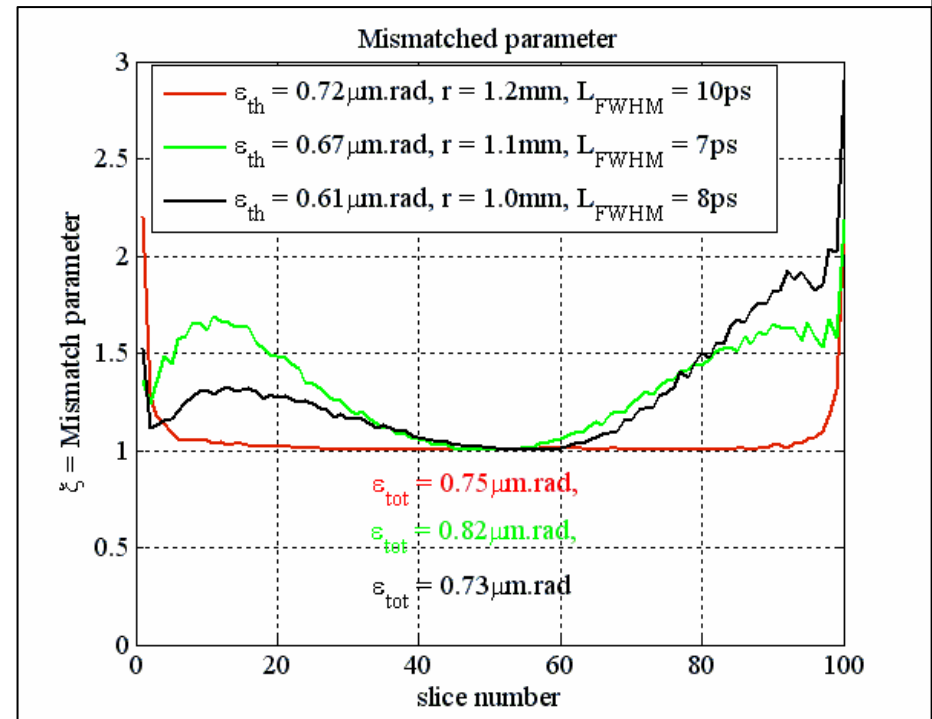
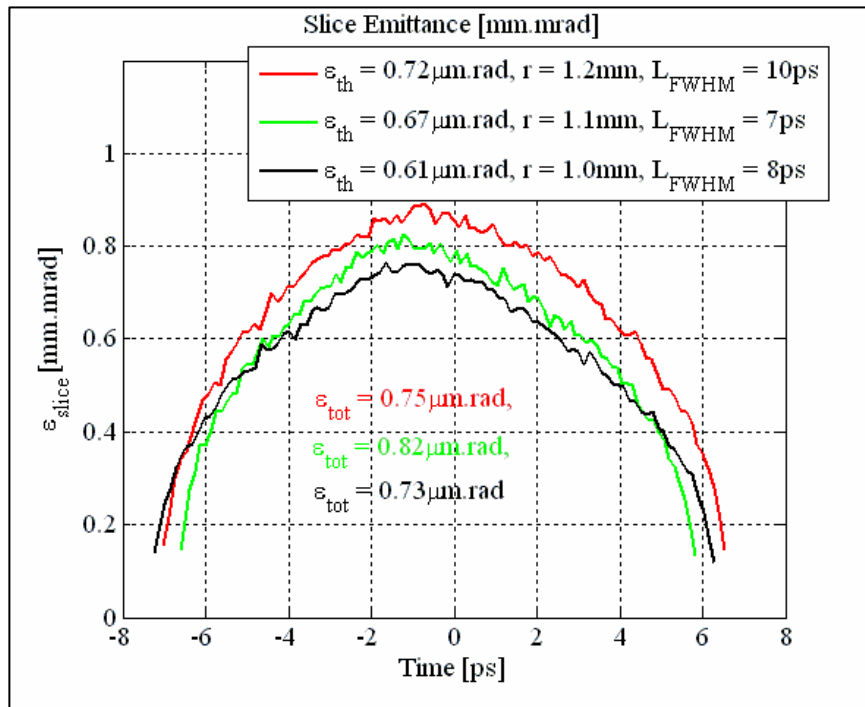


- The longitudinal phase space gets linear
- Unfortunately, in the LCLS, does not prevent the production of large spikes after bunch compressor
 - ← those spikes come from wakefield which follow λ'
 - ☀ LCLS would benefit from lower slice emittance, better matching and lower sensitivity to parameters

Optimization

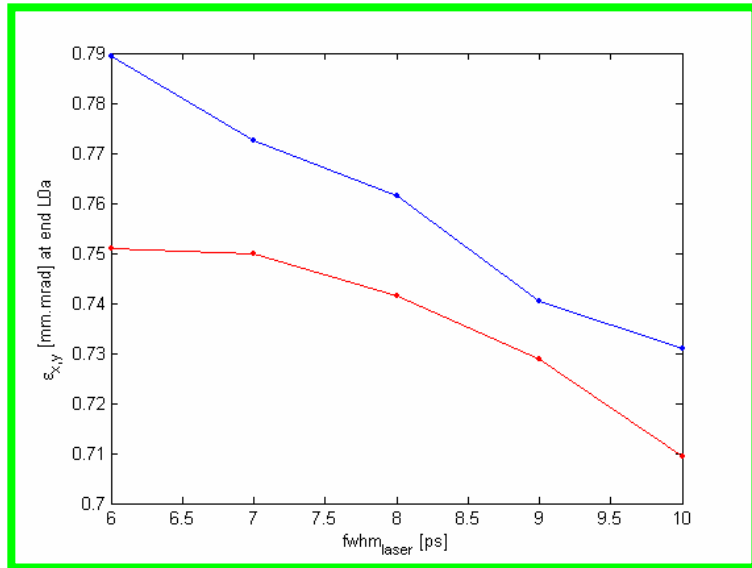
After scanning solenoid and $\phi_{RF, injection}$

$$\xi = \frac{1}{2}(\beta_o \gamma - 2\alpha_o \alpha + \beta \gamma_o)$$

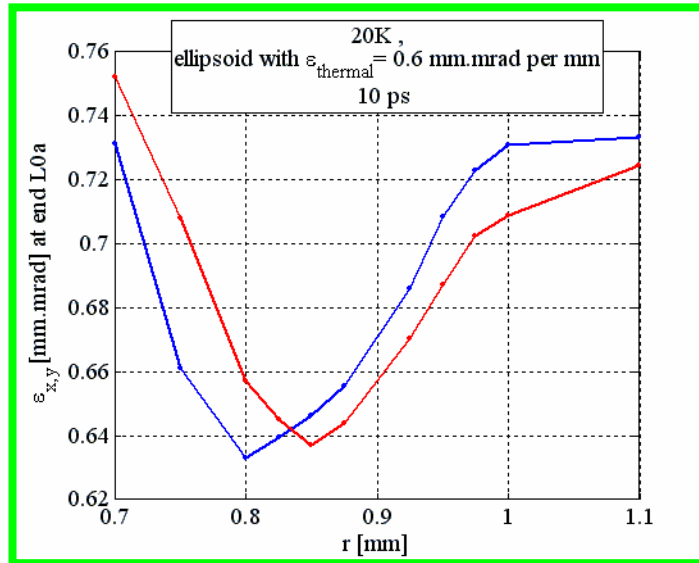


Too small r or too small length \Rightarrow more mismatch

Optimization vs pulse length and radius



Vs laser pulse length

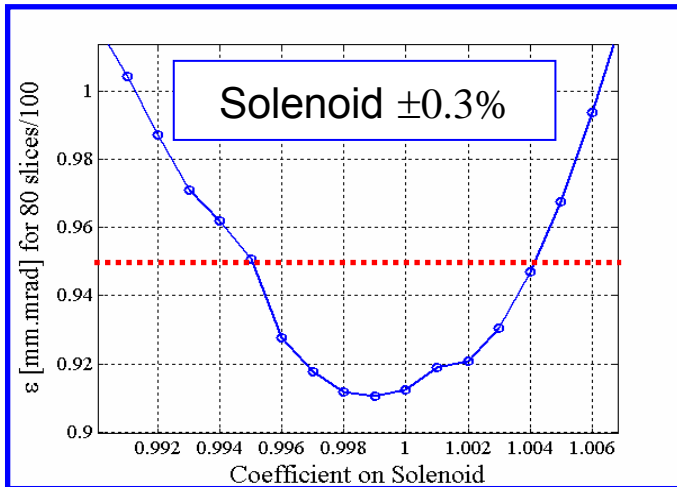
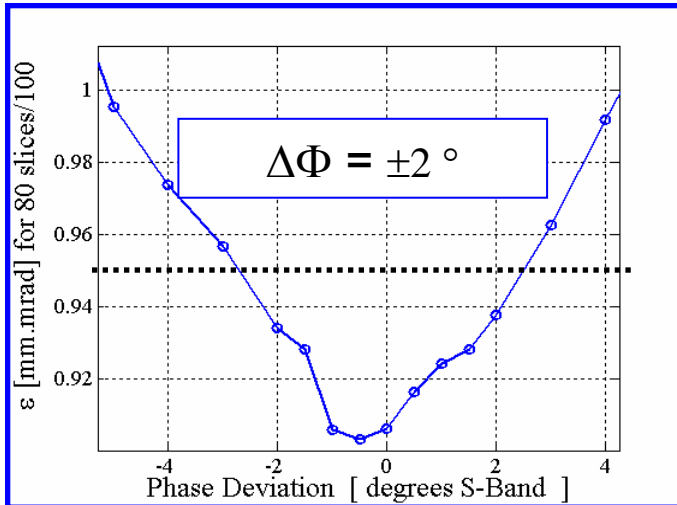


Vs laser spot size radius

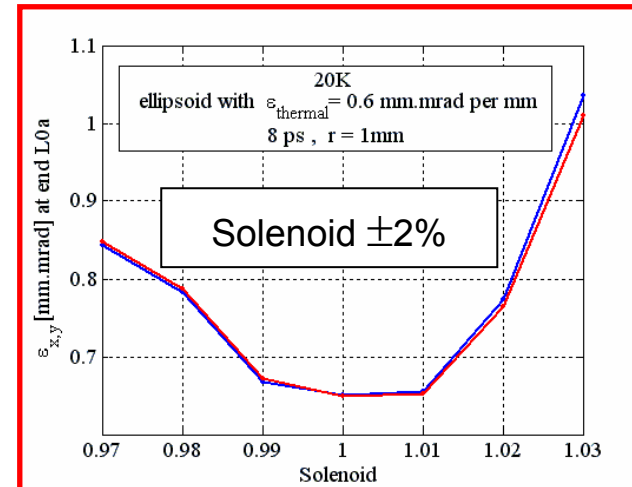
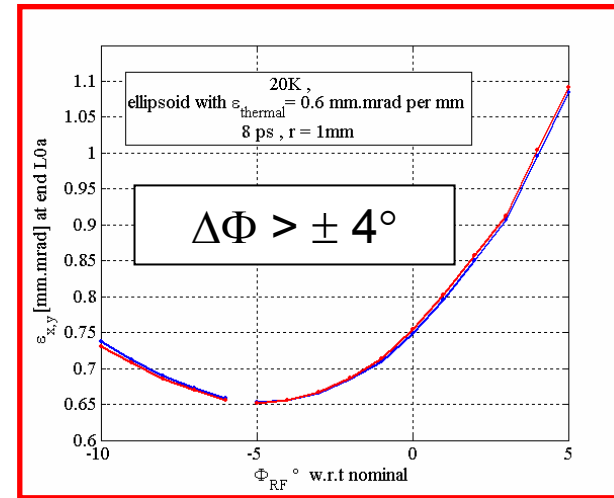
- Increasing pulse length reduces emittances
 - limited by ϵ_{RF} and desired pulse length before compressors
- Optimum radius would be between 0.8 and 1mm
 - unfortunately at 0.8 mm, too strong image charge distorts bunch profile;
 - 1mm gives better matching

Much less sensitive !

“Beer can”



Ellipsoid



Tuning will be much easier in 19D-parameter space

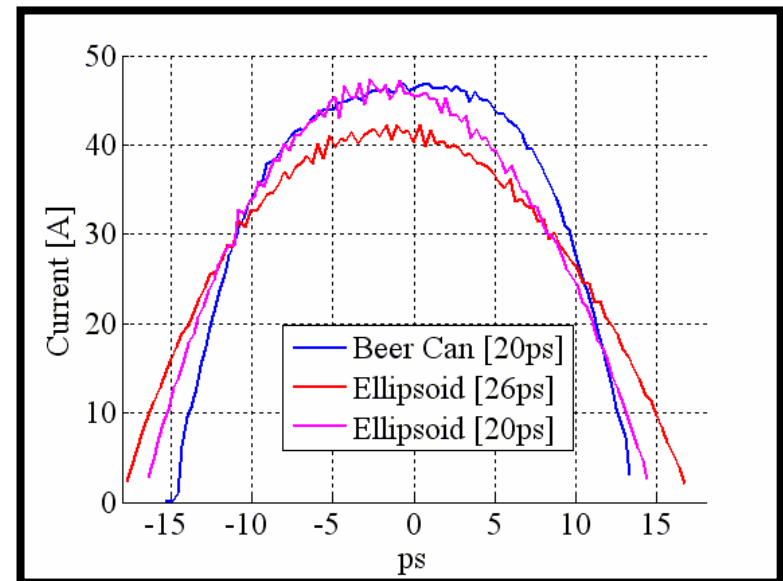
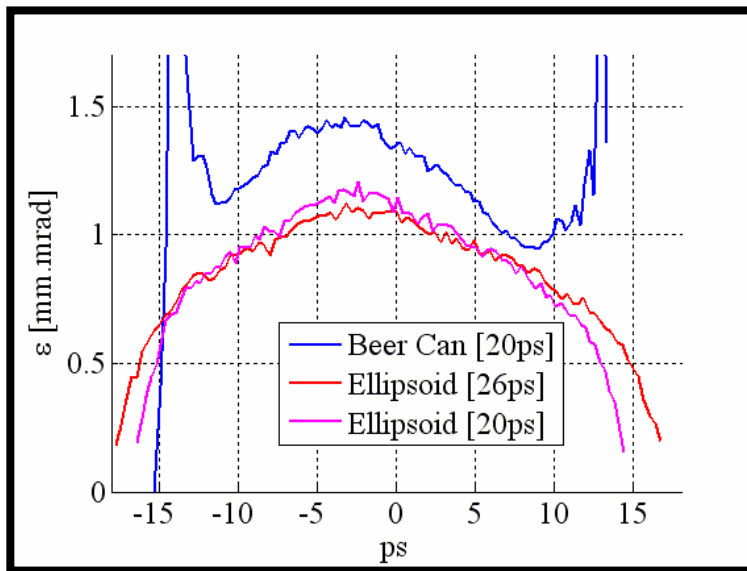
How much distortion on that perfect shape until we start losing this low sensitivity ?

Optimization for L-Band Gun

- 1nC, with little effort in optimizing/retuning

L-Band gun 40MV/m, $\phi = 33^\circ$

ε at 140 MeV

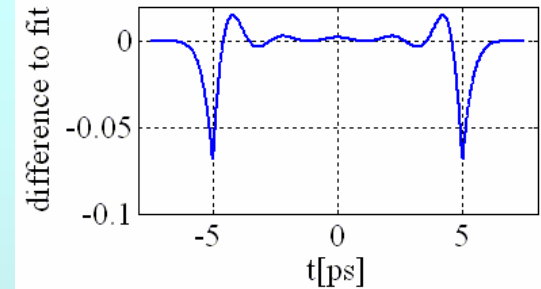
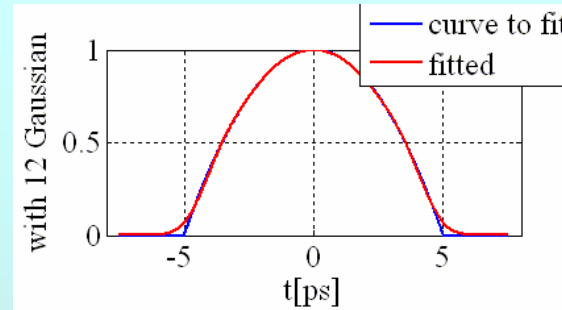
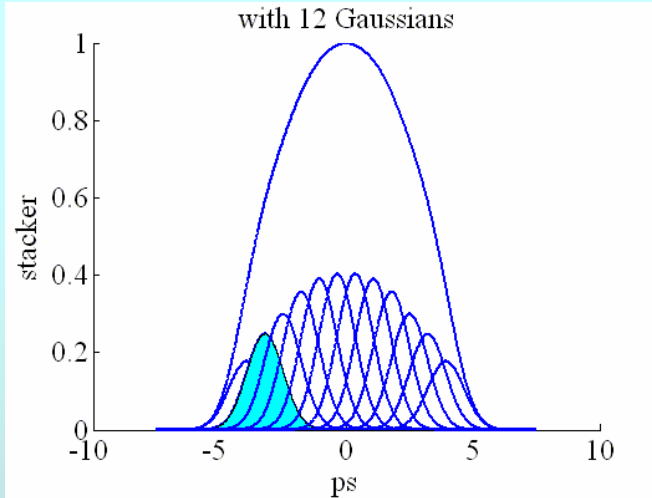


$\varepsilon = 1.42$ mm.mrad; $\varepsilon_{80\%} = 1.34$ mm.mrad

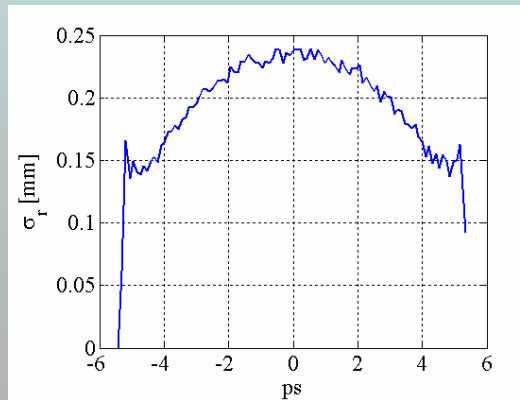
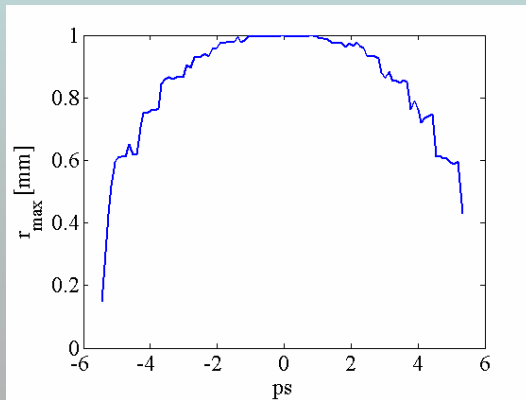
$\varepsilon = 0.93$ mm.mrad ; $\varepsilon_{80\%} = 0.96$ mm.mrad

$\varepsilon = 1.02$ mm.mrad; $\varepsilon_{80\%} = 1.03$ mm.mrad

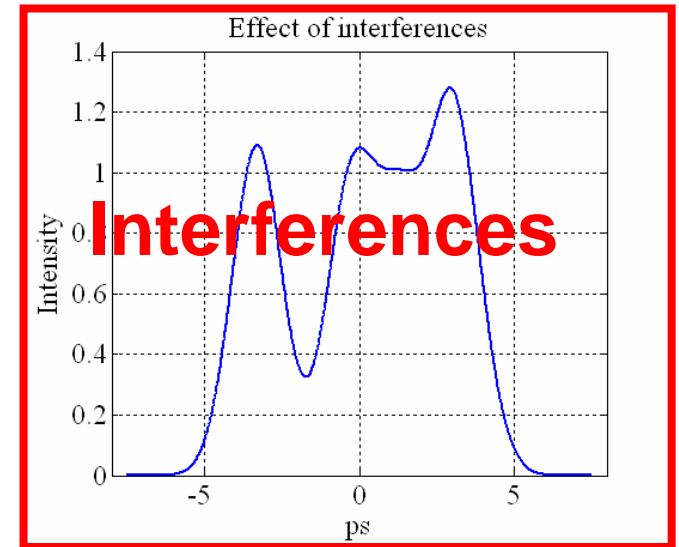
Stacking pulses



6+6 beamlets of different radii

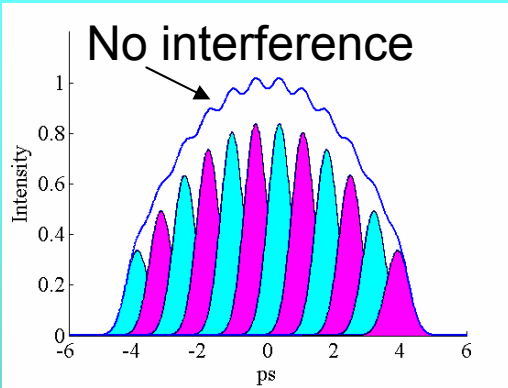


Gaussians Wash out discrete steps of rms value

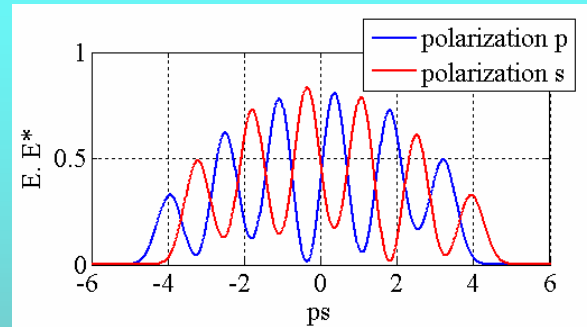


Fighting interferences in Stacker

Alternating polarization + appropriate choice of σ , interference effect is minimized

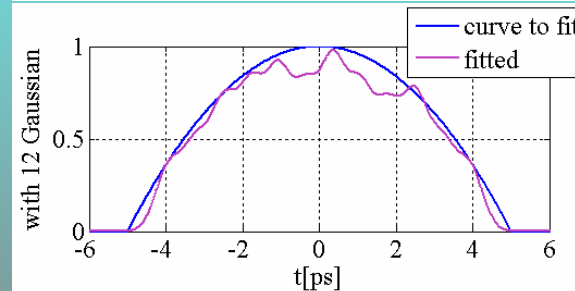


Interferences random phases



$$E_p = \sum_i A_{2i} e^{-\frac{(t-t_{2i})^2}{4\sigma^2}} e^{i2\pi\phi_i}$$

$$E_s = \sum_i A_{2i+1} e^{-\frac{(t-t_{2i+1})^2}{4\sigma^2}} e^{i2\pi\phi_i}$$



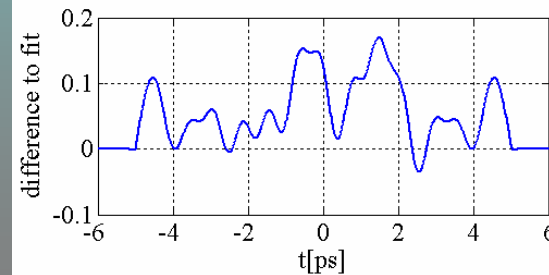
$$I = I_p + I_s$$

$$I_p = E_p \cdot E_p^*$$

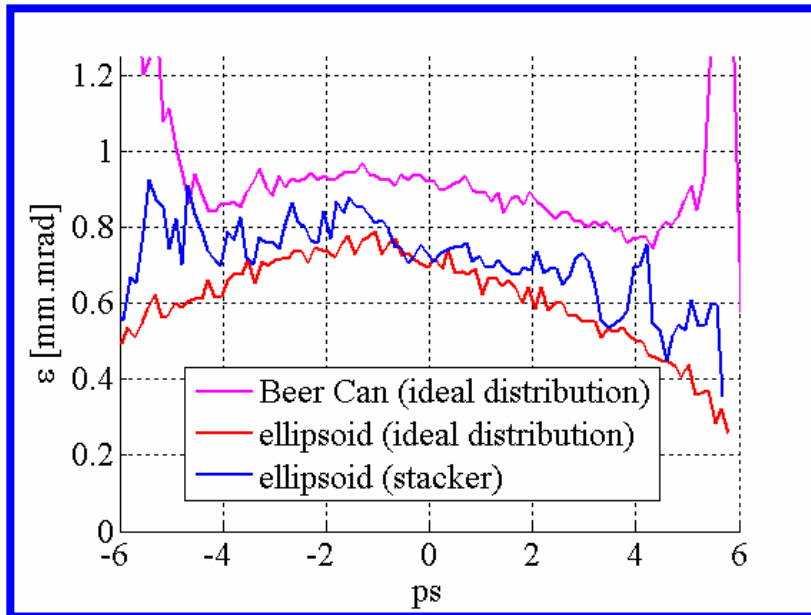
$$I_s = E_s \cdot E_s^*$$

~<15 %

**for all
draws**



PARMELA simulations using stacker distributions



Beer Can

IDEAL

Direct beer can

Ellipsoid ideal

IDEAL

50 Beamlets no interference

Stacker

12 Beamlets and random phase

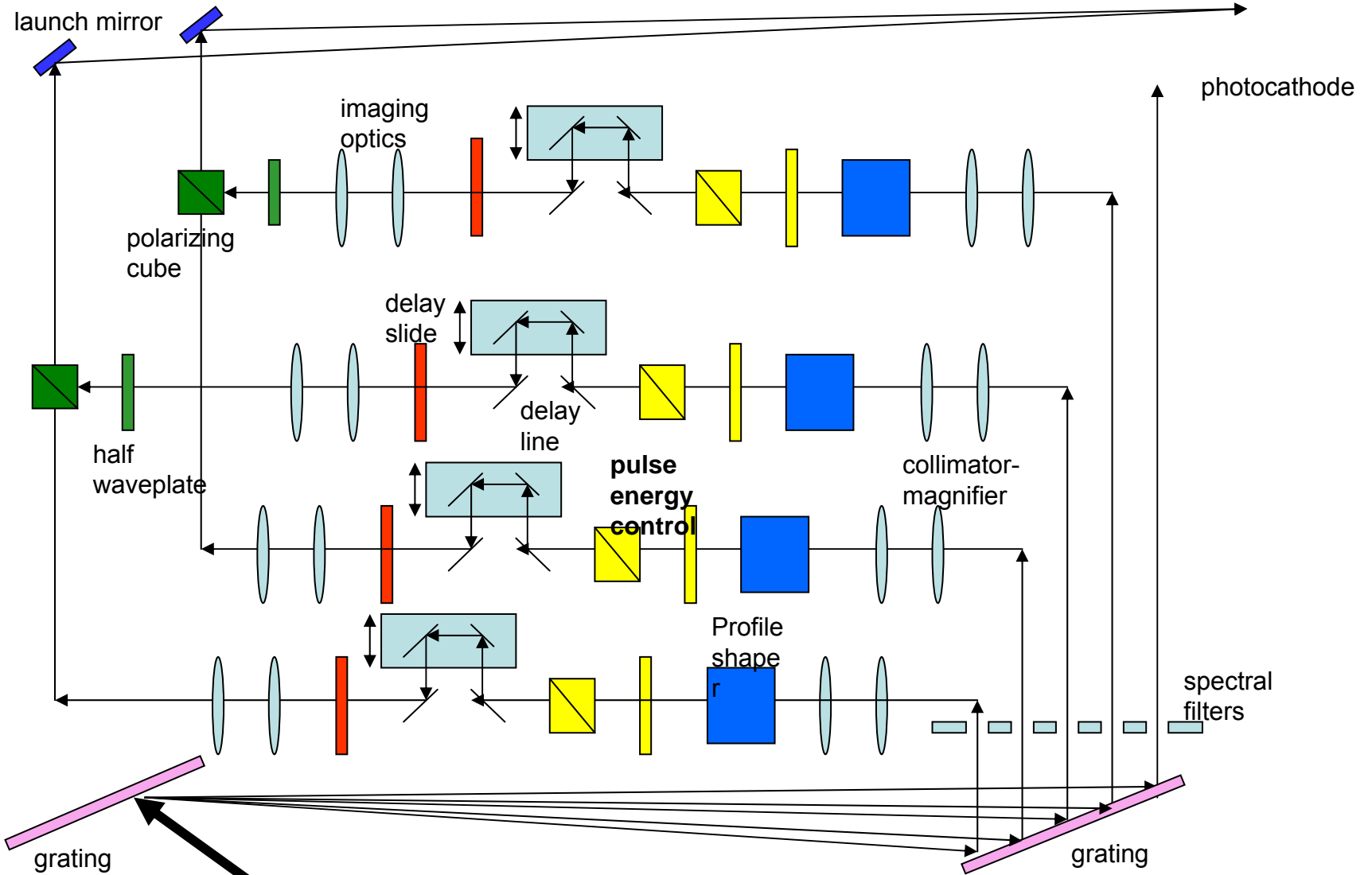
NOT IDEAL

$\epsilon = 1.02$ mm.mrad; $\epsilon_{80\%} = 0.95$ mm.mrad

$\epsilon = 0.71$ mm.mrad ; $\epsilon_{80\%} = 0.71$ mm.mrad

$\epsilon = 0.80$ mm.mrad; $\epsilon_{80\%} = 0.80$ mm.mrad

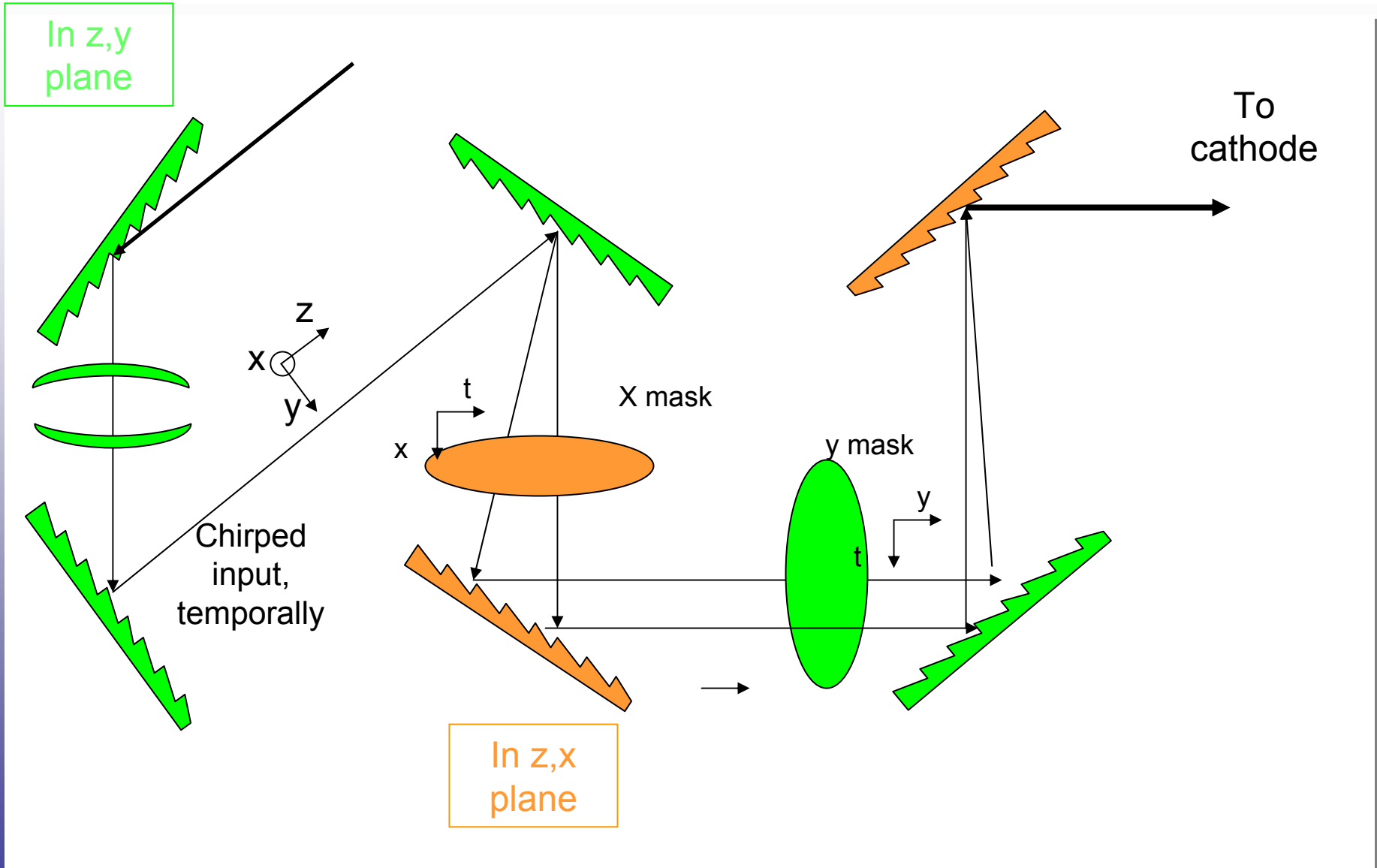
Stacker Layout



To the Courtesy of P.Bolton

“what to try to avoid...” from P.Bolton

Spectral Control Principle



Production of the 3D ellipsoidal pulse

■ Two solutions proposed

■ Pulse Stacker

- Too complex
- Too lossy
- Uses too much space
- Technically feasible with many \$\$\$\$\$\$ for
 - controls, to achieve alignment , timing
 - measurement to adjust amplitude coefficient

■ Spectral Control technique

UV shaping using Four-gratings with masking array in dispersive environment

- Principle :
 - for highly chirp beam ,projects (t,x) into a 2D surface , use masking matrix (2D)
 - A second pair of gratings : same for (t,y)
- masking technology for IR exists
 - but given present difficulties direct UV might be more appropriate; masking technology needs to be developed (transmissive or reflective scheme)
- fluence limits on optics (even worse upstream)
- efficiency low
- probably better for space and money than previous solution

Conclusion

- Ideal emission pulse = “3d-ellipsoid” not “beer can”
 - Perfect emittance compensation in high charge regime
 - Impressively less sensitive to tuning parameter
 - tolerances are 1 order of magnitude above those defined for “beer can” pulse
 - More exploration required for L-Band gun
 - Exploration for low gradient gun (10MV/m)
- Ellipsoidal Laser Pulse is a Technical challenge
 - maybe slightly more challenging than “beer can” generation?
 - if direct UV shaping is considered for “beer can”, the “ellipsoid generation” shares many of the same difficulties

References

- [1] Yang, Sumitomo Industries
- [2] B.Graves, DUVFEL
- [3] J.Schmerge, GTF
- [4] O.J.Luiten, et al. “How to realize uniform 3-dimensional ellipsoidal electron bunches”, Phys.Rev. August 2004